Via EFS Web

Deposit Date: July 6, 2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: YAMAKAWA, Naomi Attorney Docket No.: 2352.016

Serial No.: 10/590,122 Group Art Unit: 1632

Filed: August 18, 2006 Examiner: Unknown

Title: DNA ARRAY FOR ANALYZING DNA METHYLATION, METHOD OF

PRODUCING THE SAME AND METHOD OF ANALYZING DNA

METHYLATION

To: Commissioner for Patents

Office of Initial Patent Examination's Filing Receipt Corrections

P.O. Box 1450

Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Applicants attach herewith a copy of the Official Filing Receipt relative to the above-identified patent application.

Under the section entitled **Assignment for Published Patent Application**, the second Assignee: Tokyo Metropolitan Foundation for Research on Agin g & Promotion of Human Welfare, Tokyo Metropolita, Tokyo, JAPAN is incorrect. We have circled the errors. Please replace the second Assignee on the Filing Receipt with the correct name and address: Tokyo Metropolitan Foundation for Research on **Aging** & Promotion of Human Welfare, Tokyo, JAPAN.

If you have any questions, please contact applicants' undersigned attorney.

Respectfully submitted

Kathy Smith Dias

Attorney for Applicants Registration No. 41,707

Dated: July /0, 2008

HESLIN ROTHENBERG FARLEY & MESITI P.C.

5 Columbia Circle

Albany, New York 12203-5160 Telephone: (518) 452-5600 Facsimile: (518) 452-5579



United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS PO. BOX 1450 Alexandria, Virginia 22313-1450

APPLICATION	FILING or	GRP ART			—	·-·-
NUMBER	371(c) DATE	UNIT	FIL FEE REC'D	ATTY,DOCKET,NO	TOT CLAIMS	IND CLAIMS
10/590,122	08/18/2006	1632	1460	2352.016	13	4

CONFIRMATION NO. 9927 FILING RECEIPT

23405 HESLIN ROTHENBERG FARLEY & MESITI PC 5 COLUMBIA CIRCLE ALBANY, NY 12203

Date Mailed: 06/10/2008

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please submit a written request for a Filing Receipt Correction. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections

Applicant(s)

Naomi Yamakawa, Saitama, JAPAN:

Assignment For Published Patent Application

Japan Science and Technology Center, Kawaguchi-shi, JAPAN

Tokyo Metropolitan Foundation for Research on A Promotion of Human Welfare Tokyo

(Metropolita) Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 23405

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP2005/002490 02/17/2005

Foreign Applications

JAPAN 2004-044759 02/20/2004

If Required, Foreign Filing License Granted: 06/06/2008

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US 10/590,122**

Projected Publication Date: 09/18/2008

Non-Publication Request: No

Early Publication Request: No

JUN 1 2 2008

HEST SN ROTHENBERG
FARLEY & MESTER PC

Title

Dna Array for Analyzing Dna Methylation, Method of Producing the Same and Method of Analyzing Dna Methylation

Preliminary Class

435

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

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